

Flat Field Emitter Based on Ultrananocrystalline Diamond (UNCD) Film for SRF Technology

SBIR Phase II (May2016~April2018) Contract # DE-SC0013145

Chunguang Jing, Euclid Techlabs LLC

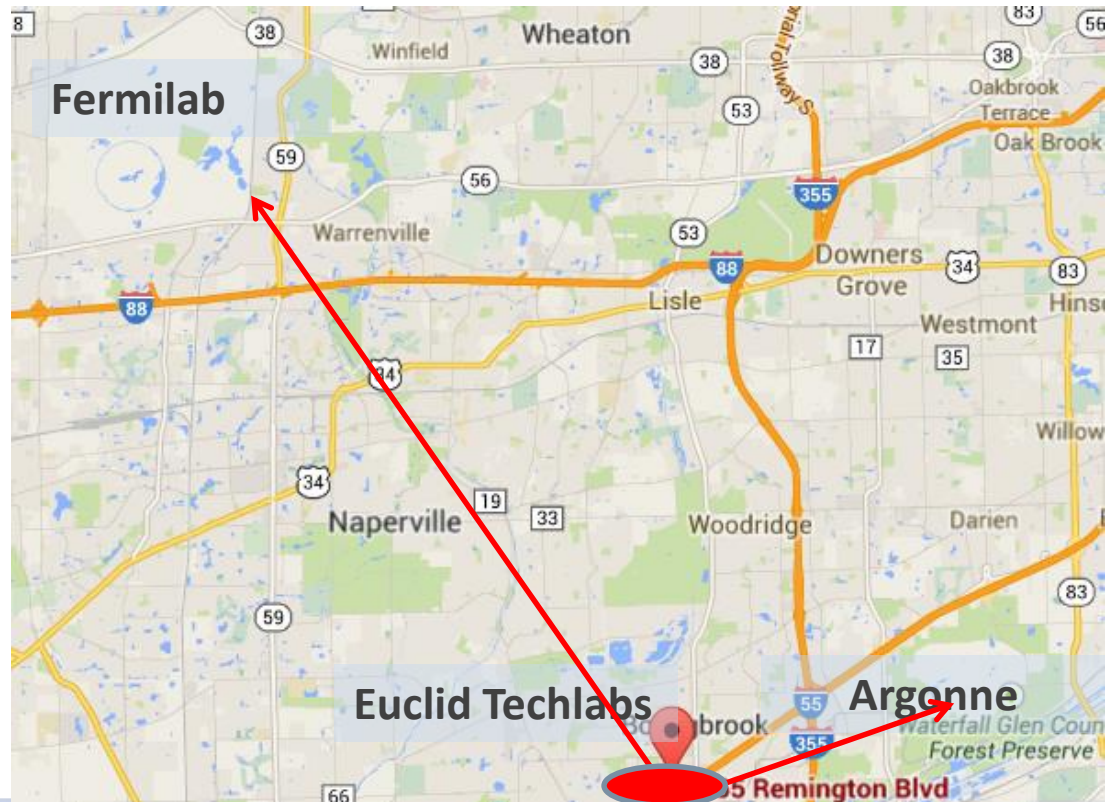
Team:

1. Euclid Techlabs (lead by Dr. Sergey Baryshev)
2. CNM, ANL (lead by Dr. Anirudha Sumant)
3. AWA, ANL (lead by Dr. Jiangang Shao)
4. TESLA, BNL (lead by Dr. Erdong Wang)

Euclid Techlabs LLC

Euclid TechLabs LLC, founded in 1999 is a company specializing in the development of advanced electrons-structure interaction apparatuses for various applications. Areas of expertise include electron accelerators, high power rf components, Photoinjectors, dielectric accelerators, diamond based electron source and other applications, etc.

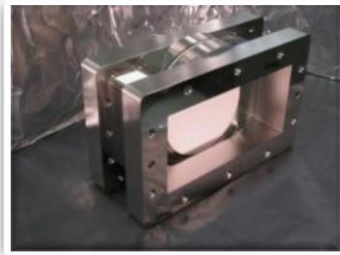
- 2016: 12 people research staff and 3 administrative,
- 2 offices: Bolingbrook, IL (lab) and Washington DC(administrative).
- Tight collaborations with National Labs and Institutes: Fermilab, ANL, BNL, LBL, LANL, Jlab, NIST, NIU, IIT, etc.



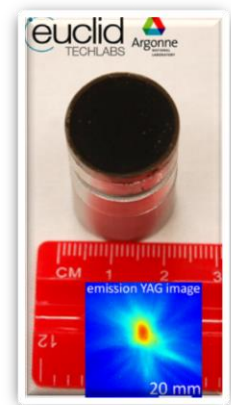
Selected Products



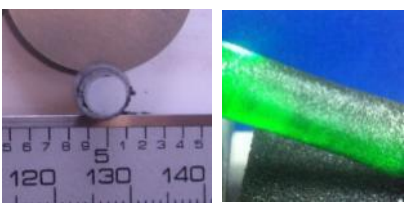
L-band high peak current LINAC



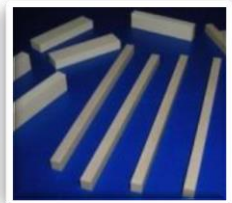
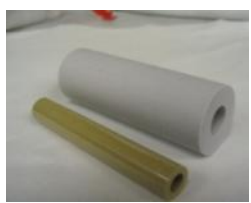
UHV L-band RF window BPM compact readout



UNCD FE cathode



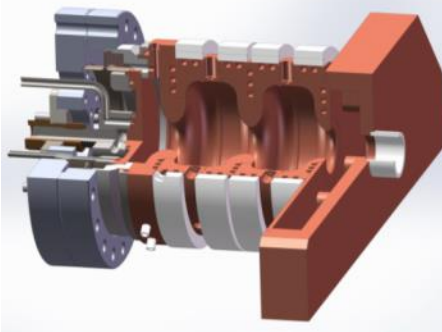
Linear and non-linear ceramics low loss; various form factors



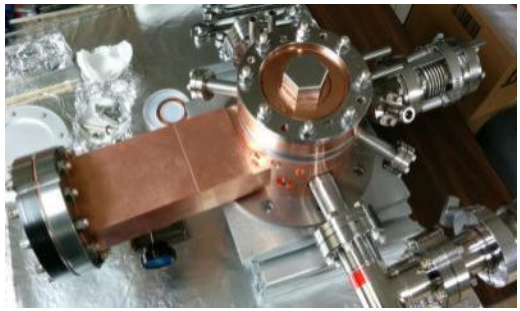
Detachable SRF coupler



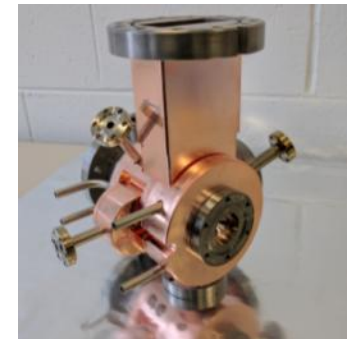
L-band 100nC Photogun



S-band 1000 pps Photogun



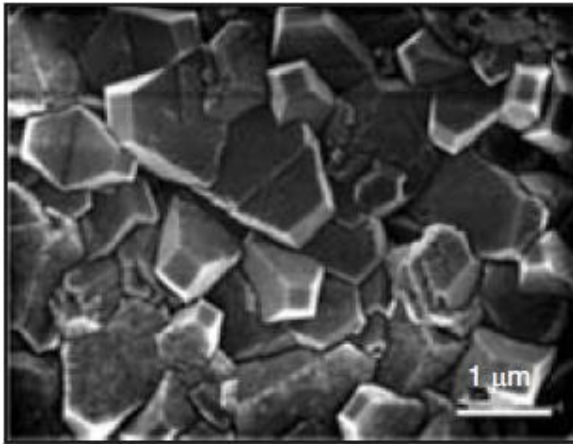
S-band 100MV/m Photogun



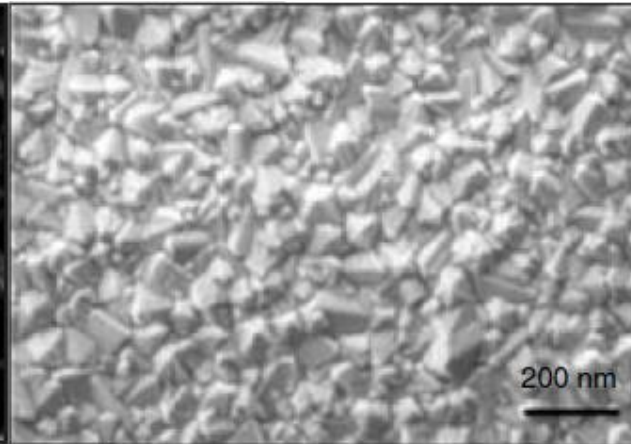
S-band Thermionic RF gun

Ultra-Nano-Crystalline Diamond (UNCD):

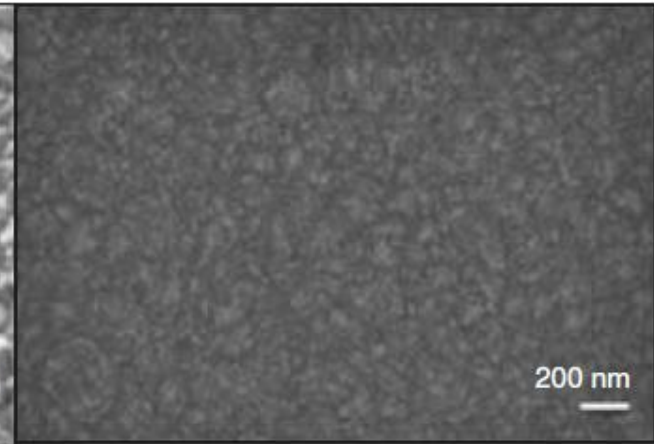
Microcrystalline:
grain ≥ 500 nm



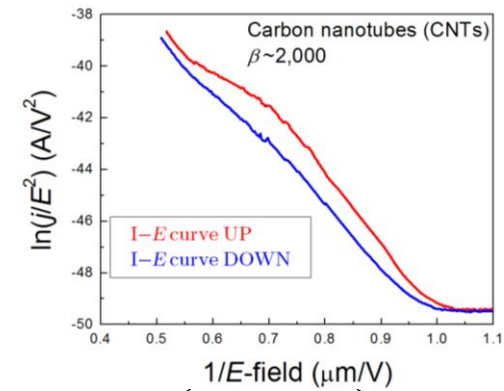
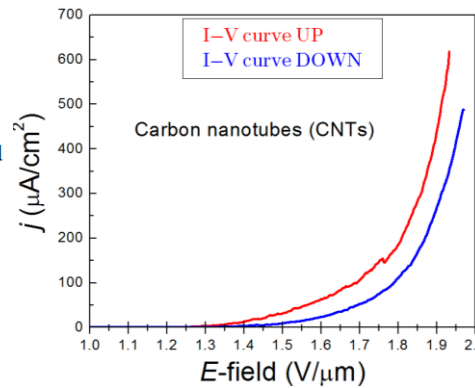
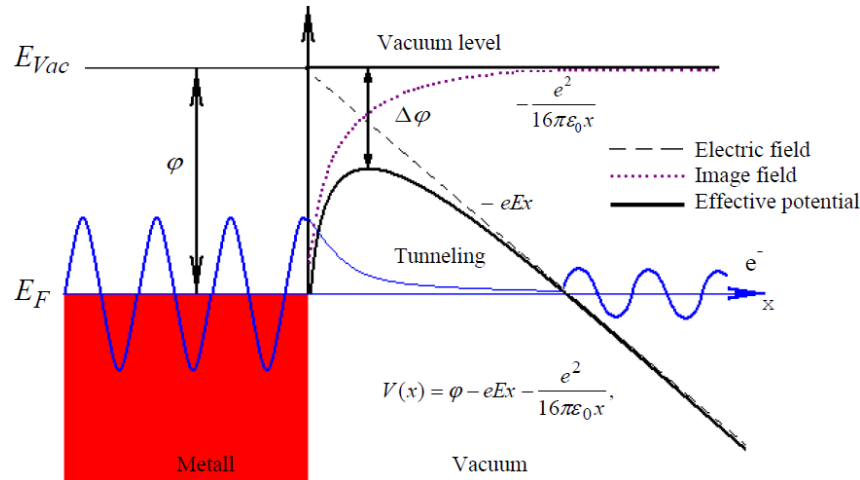
Nanocrystalline:
grain 10-200 nm



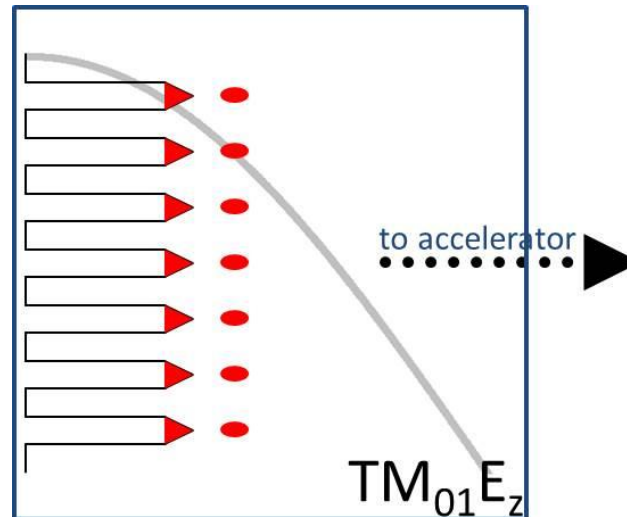
UNCD:
grain ≤ 10 nm



Field Emission: Basics and Accelerator Application



$$j_{FN}(E) = \frac{A(bE)^2}{f} \exp\left(-\frac{Bf^{3/2}}{bE}\right)$$

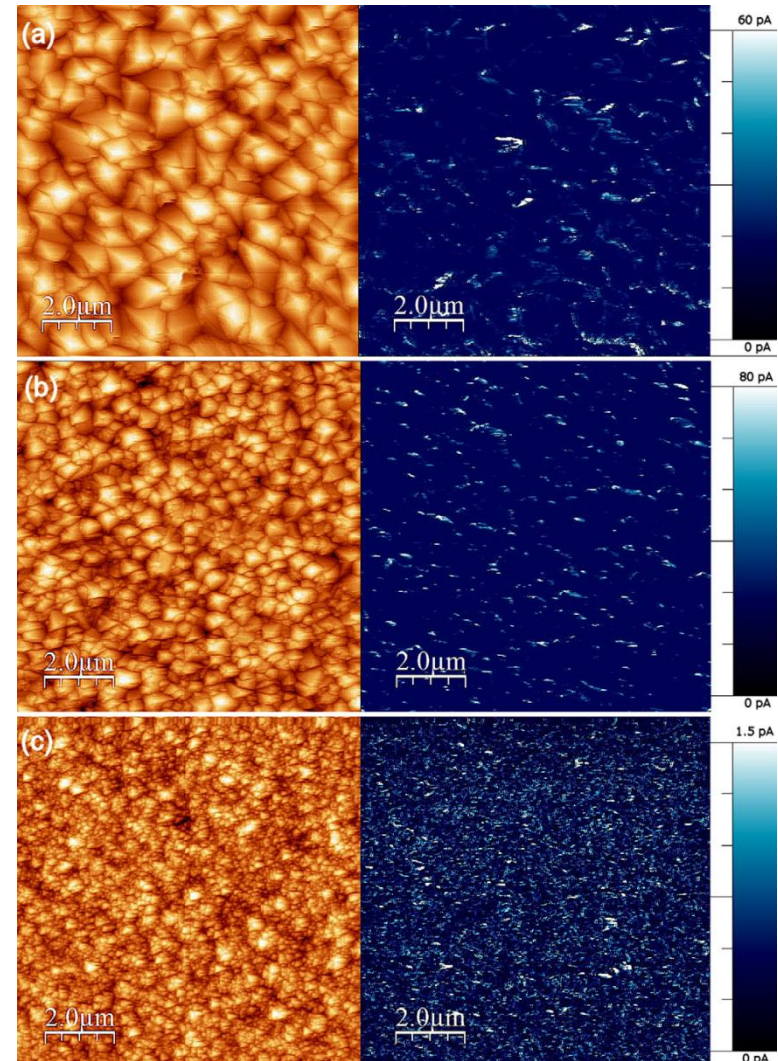


DC Field Emission: Grain Boundary (GB) is a Key

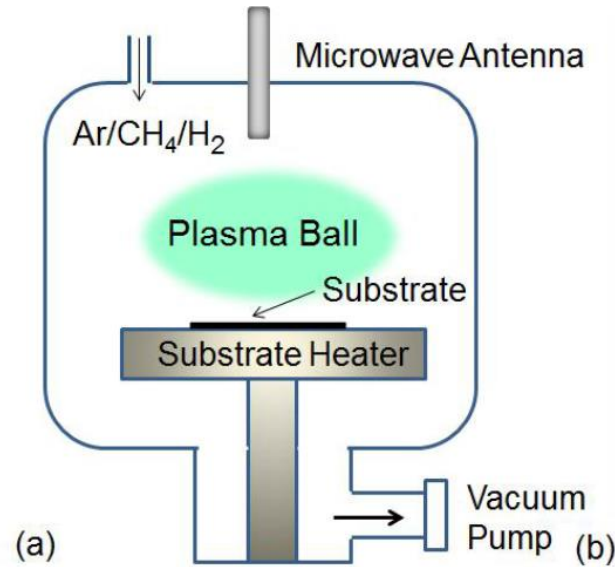
The larger GBs area the higher current field emitter may yield

UNCD has
 10^{13} emitting GBs/cm²

(compare to Spindt source with
 10^8 emitting tips/cm²)

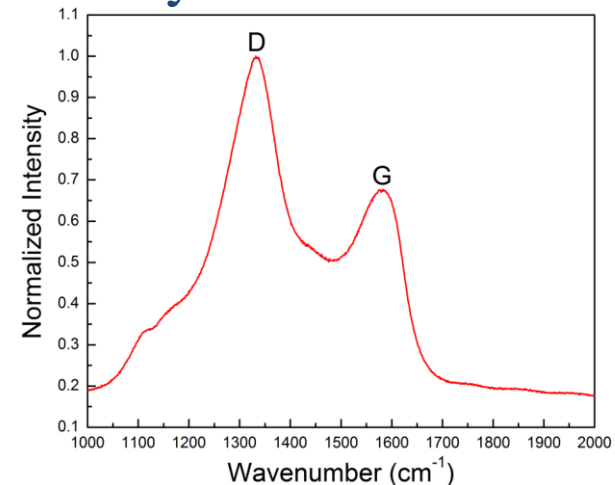
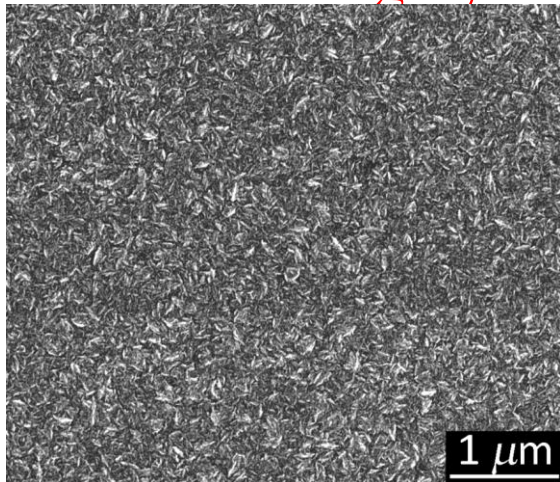


Nitrogen Doped UNCD. Basic Characterization



915 MHz
microwave-
assisted plasma
chemical vapor
deposition

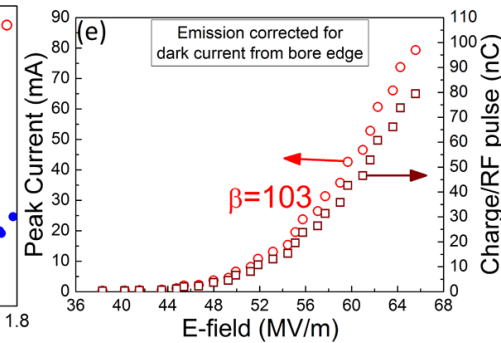
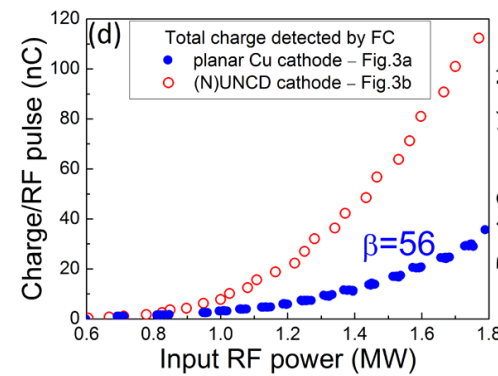
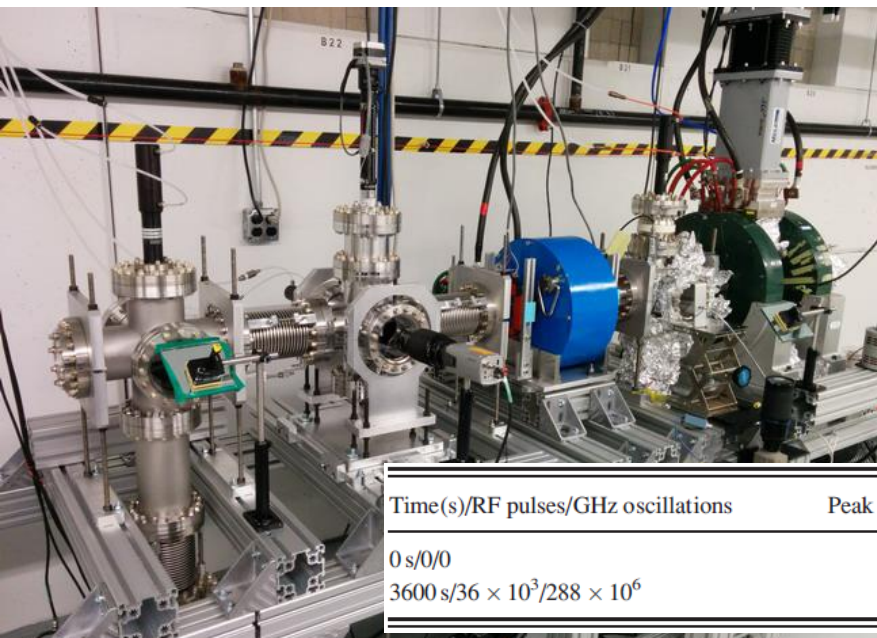
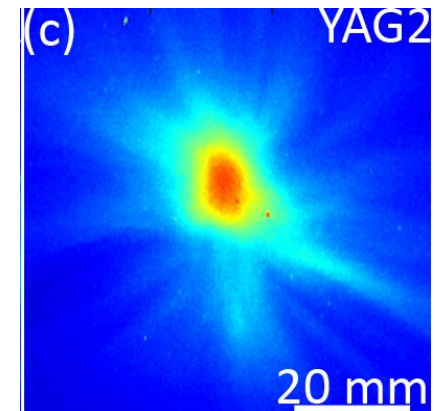
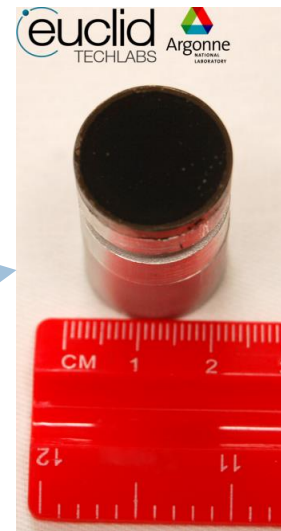
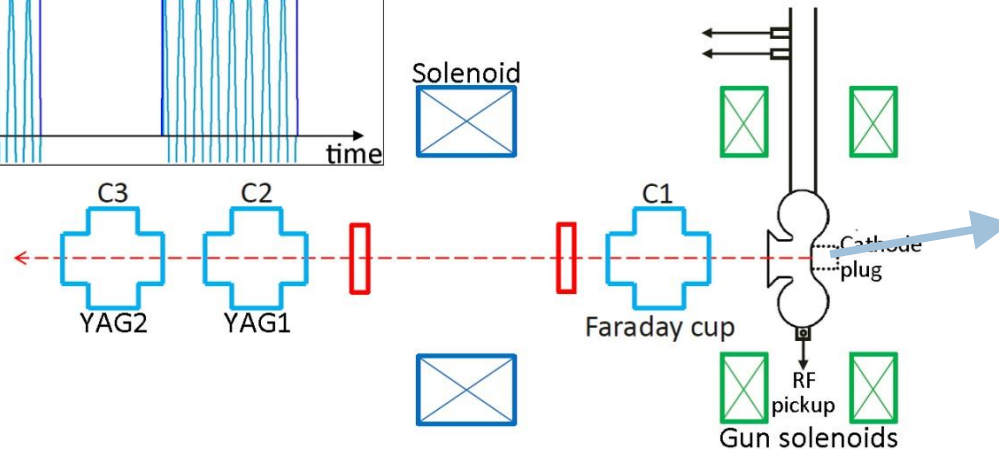
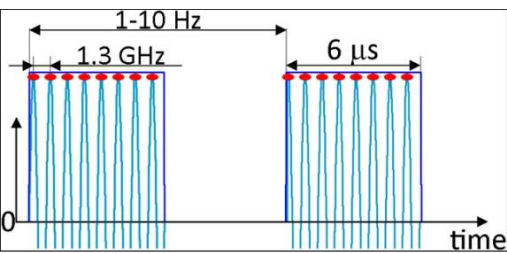
100-200 nm highly conductive (N)UNCD by SEM and Raman



Survey of UNCD FE Cathode Tests to Date

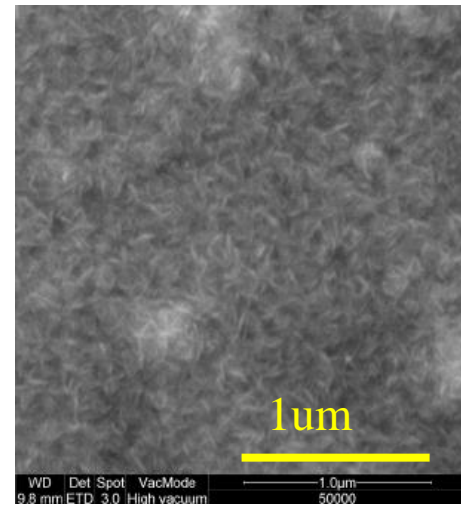
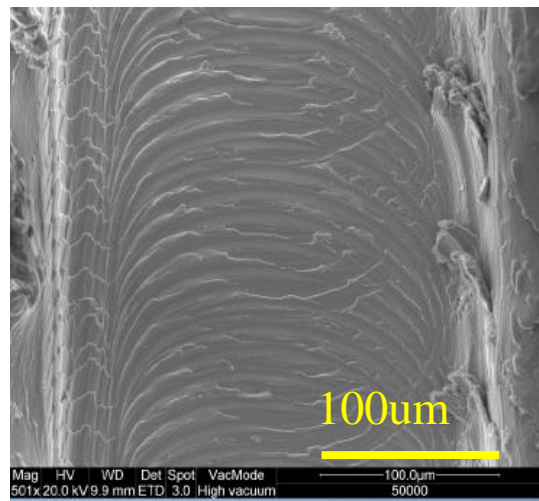
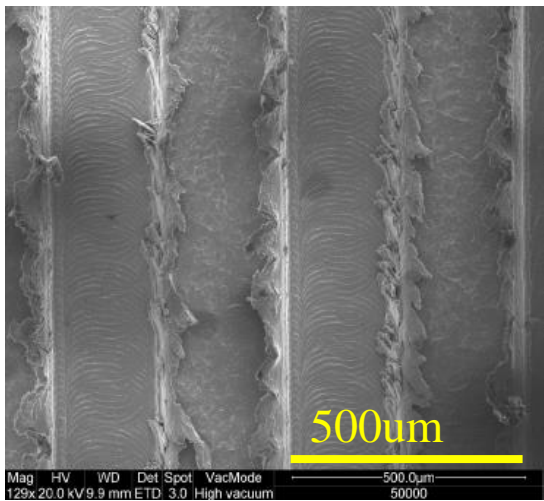
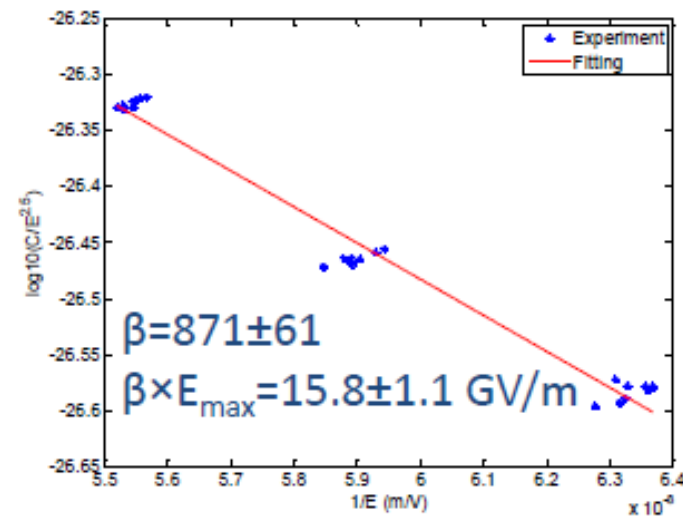
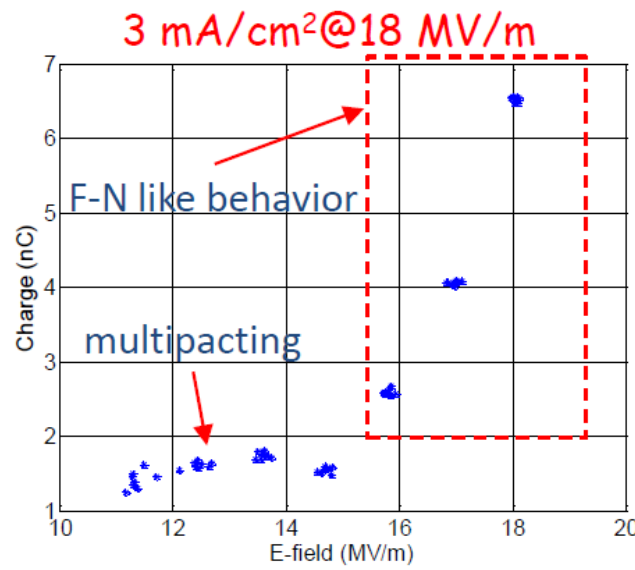
Test Platform	Description	Main Results
NC RF	<ul style="list-style-type: none">• flat cathode @ 1.3GHz RF gun , AWA facility (Prior to Phase 2)• grooved cathode @ 1.3GHz RF gun of AWA facility (Phase 1)• flat cathode @ 9GHz compact RF gun developed at Euclid (Phase 2)	<ul style="list-style-type: none">➤ operating up to 65 MV/m, 6ns pulse width, peak currents of 80 mA (equivalent to 25 mA/cm²), core beam emittance of 1.5 mm×mrad/mm-rms➤ compact X-band electron source, operating at 45MV/m, 1ns pulse width for 2 weeks.
SRF	<ul style="list-style-type: none">• Nb base cathode @ 1.3GHz SRF gun of BNL (Phase 2)	<ul style="list-style-type: none">➤ the first FE SRF cathode➤ 3mA/cm² @ ~1 MV/m under 2 Kelvin
DC	<ul style="list-style-type: none">• flat cathodes @DC emission teststand developed at Euclid (Phase 2)• flat cathodes @ DC emission imaging system developed at Euclid (Phase 2)	<ul style="list-style-type: none">➤ automatic I/V characterization➤ life time emission test➤ with help of the in situ emission imaging system, the UNCD emission features were first time revealed.

Flat UNCD FE Cathode tested at AWA

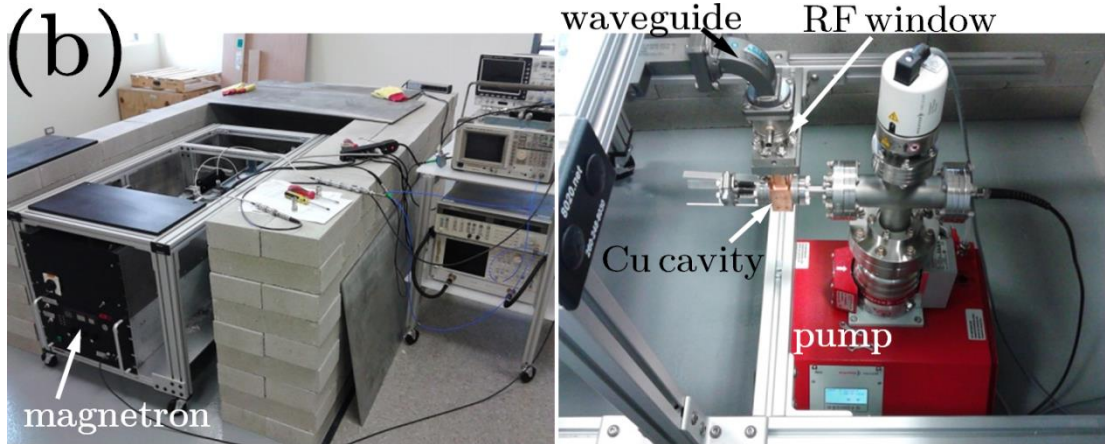
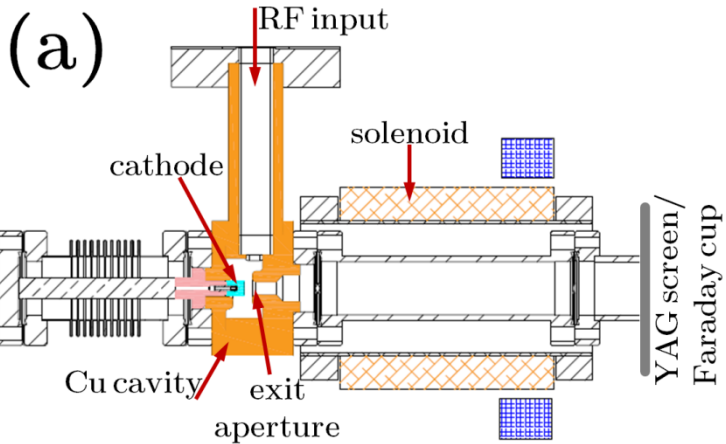
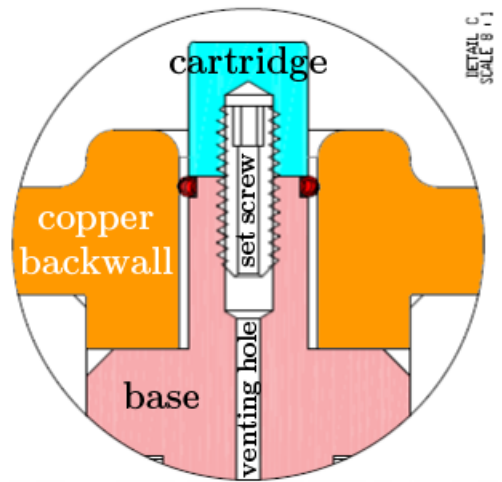
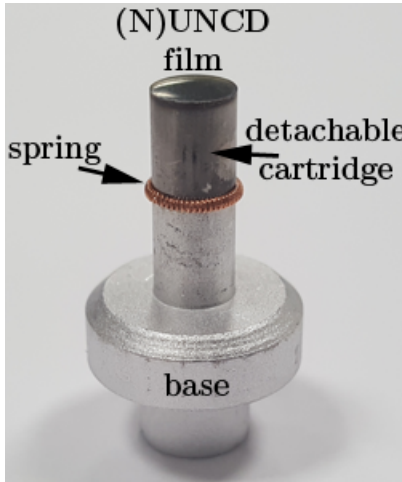
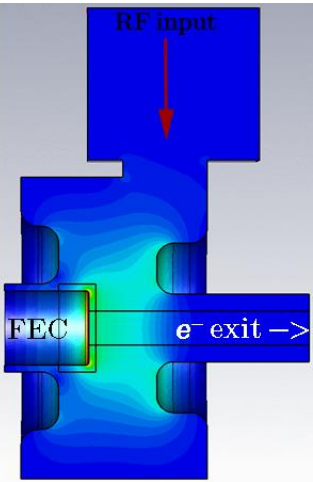
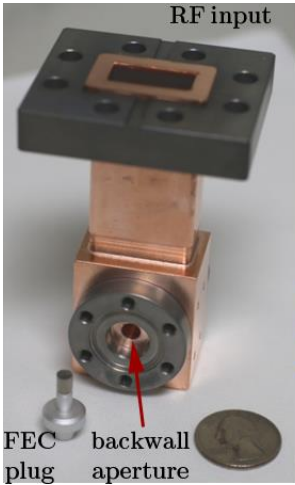


Time(s)/RF pulses/GHz oscillations	Peak current (mA) at 45 MV/m	Peak current (mA) at 55 MV/m	Peak current (mA) at 65 MV/m
0 s/0/0	1.56 ± 0.08	19.54 ± 0.98	79.37 ± 3.97
3600 s/ 36×10^3 / 288×10^6	1.47 ± 0.07	19.24 ± 0.96	79.26 ± 3.96

Grooved UNCD FE Cathode tested at AWA

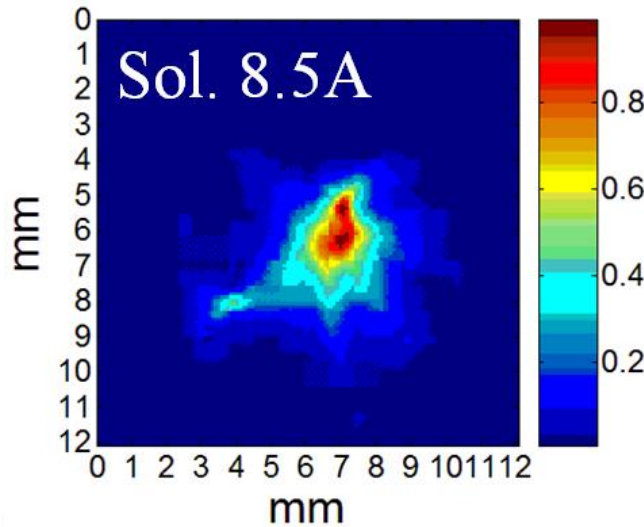
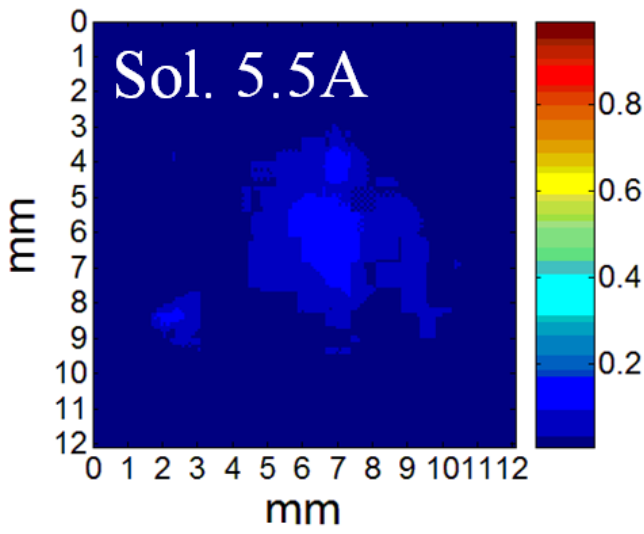


(N)UNCD Cathode in X-band 9 GHz Gun

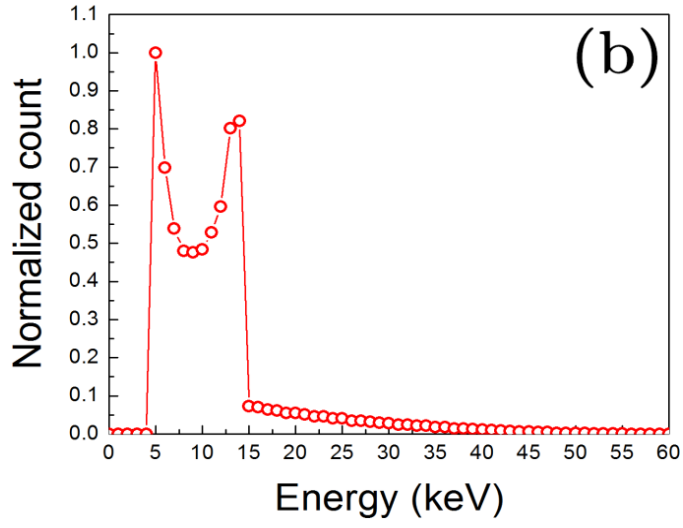
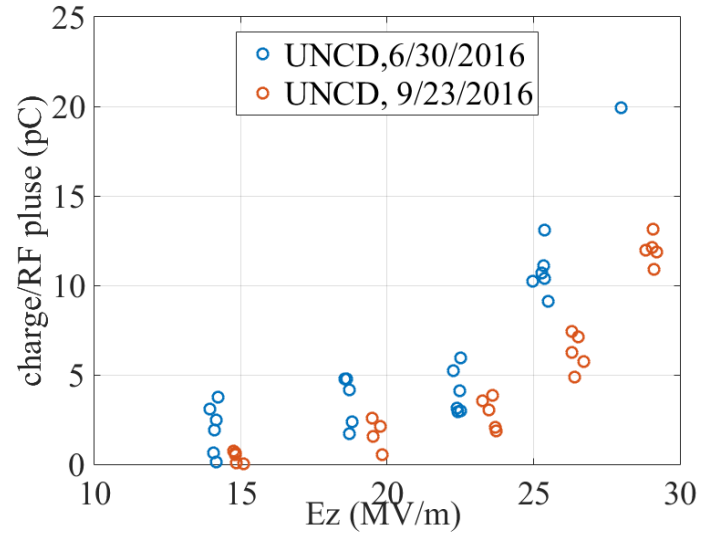


(N)UNCD in X-band 9 GHz Gun Results

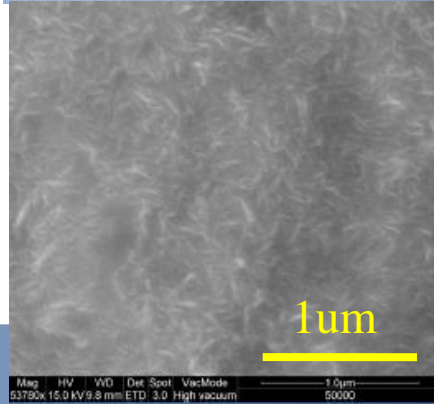
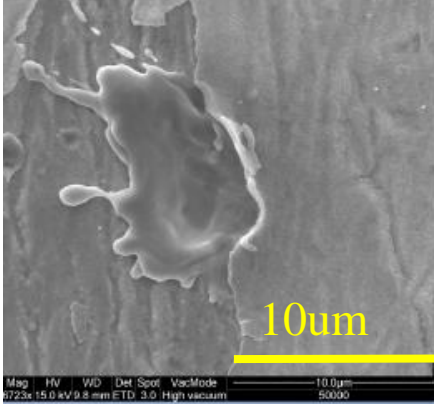
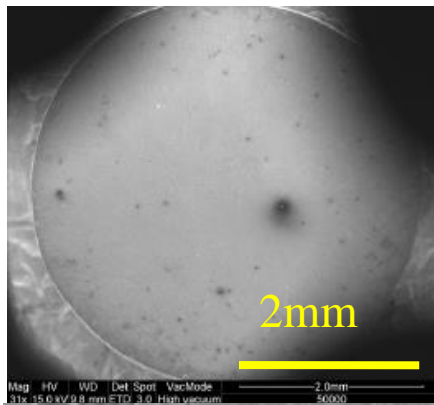
YAG image



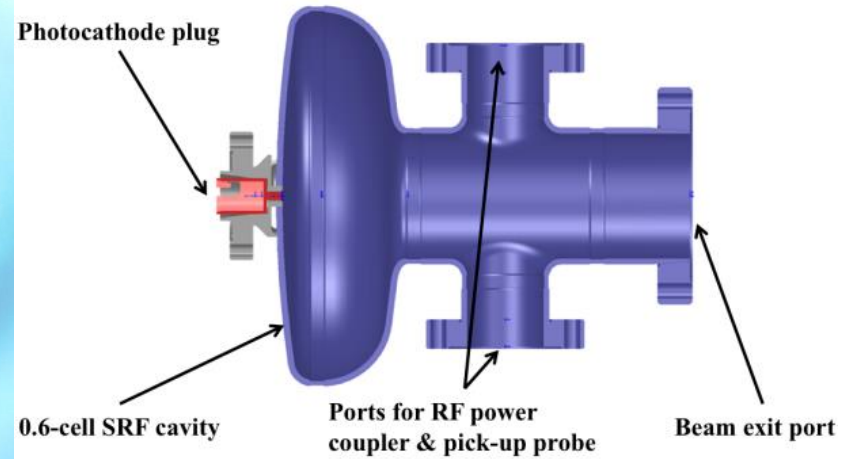
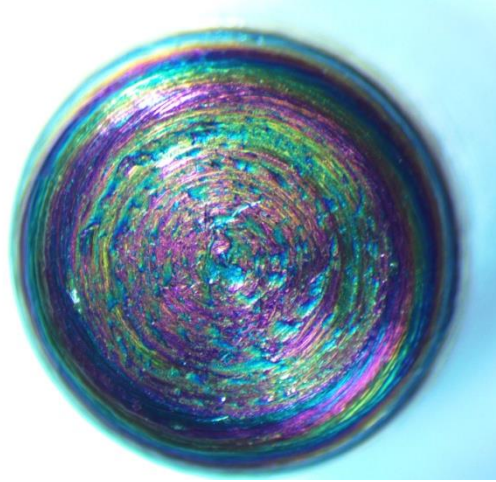
Faraday cup signal:
2 mA/cm²@28 MV/m



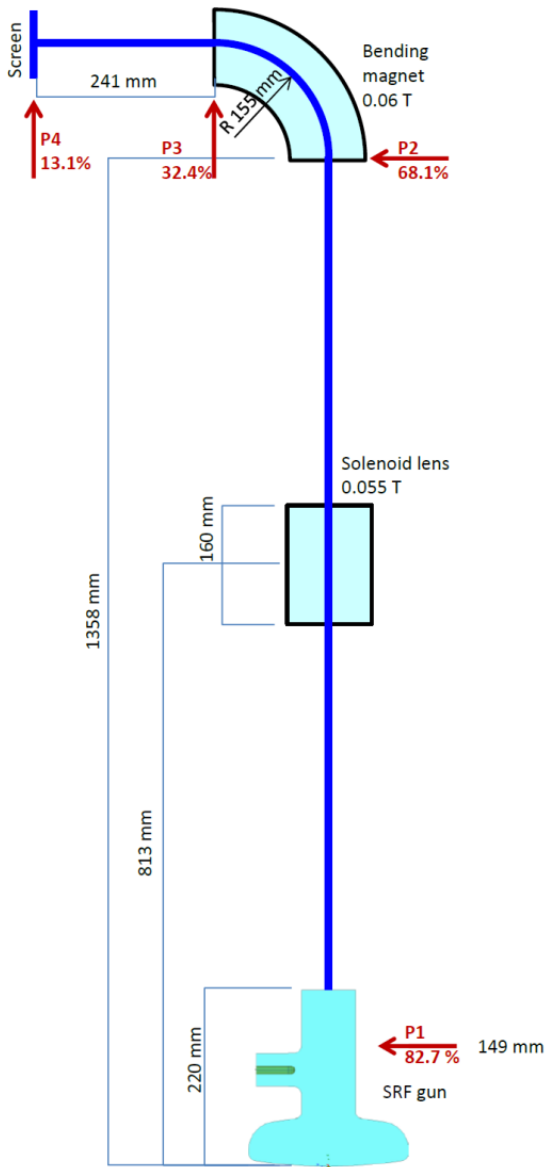
Post test SEM



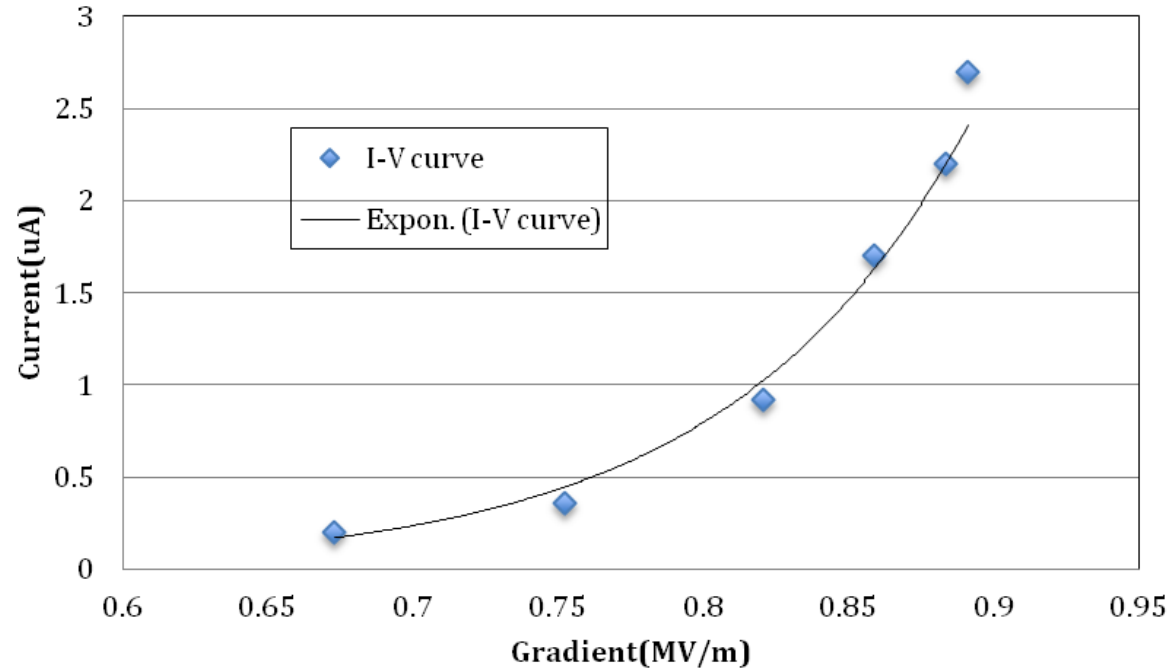
(N)UNCD emitter in TESLA 1.3 GHz gun:



First to Date Experimental Emission Data

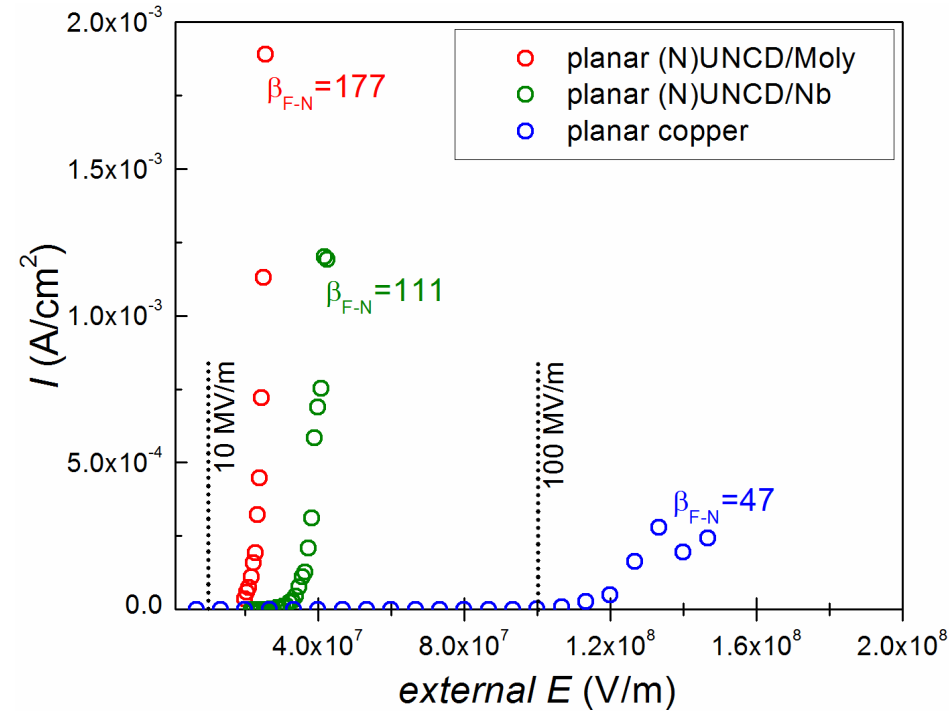


3 μA \rightarrow 3 mA/cm² @
 ~1 MV/m under 2 Kelvin

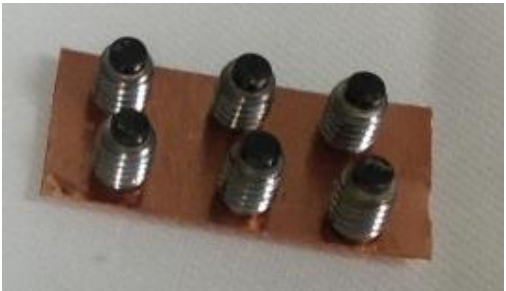


~ Emitted in the gun
 ~ Detected at P4, 1.5 m away from the gun
 after 90° bending magnet

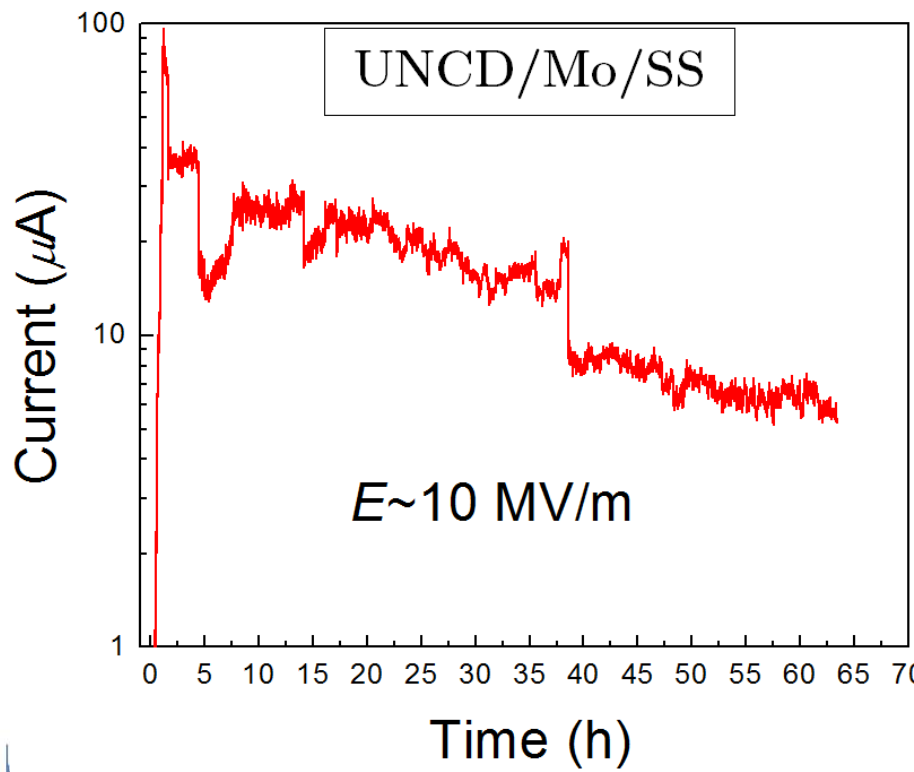
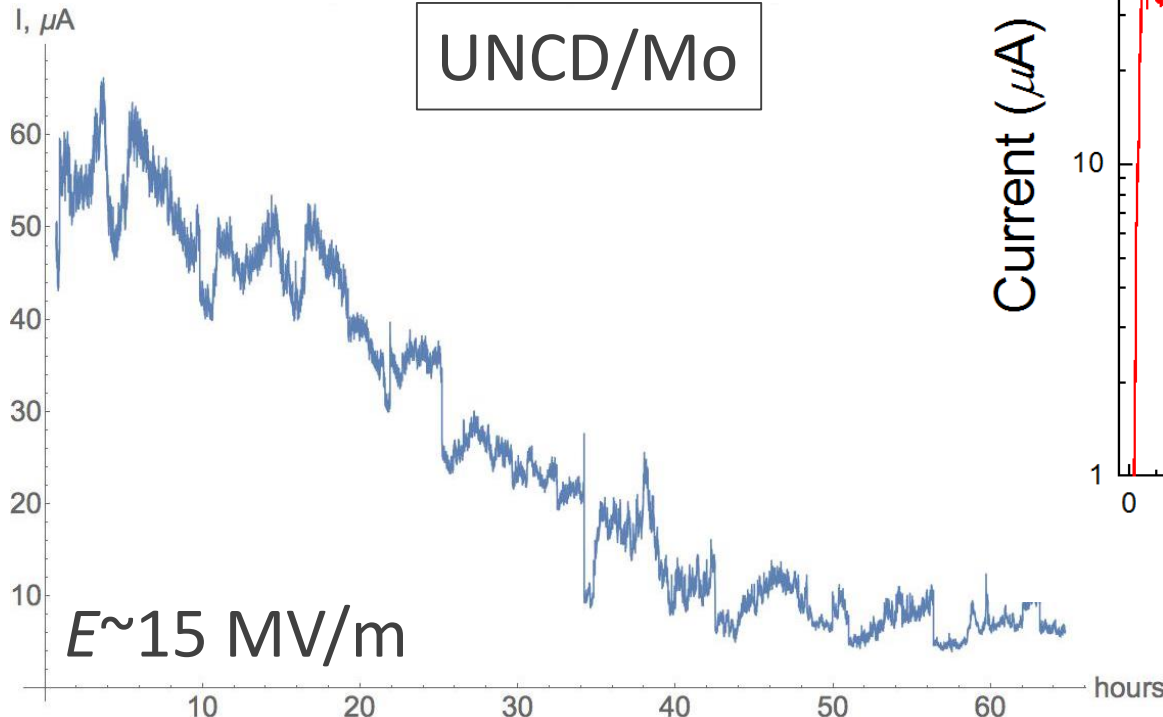
(N)UNCD at DC Test Stand: I/V curve



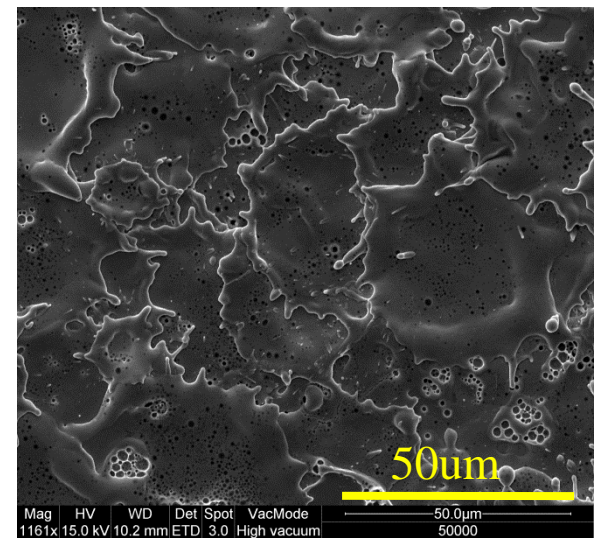
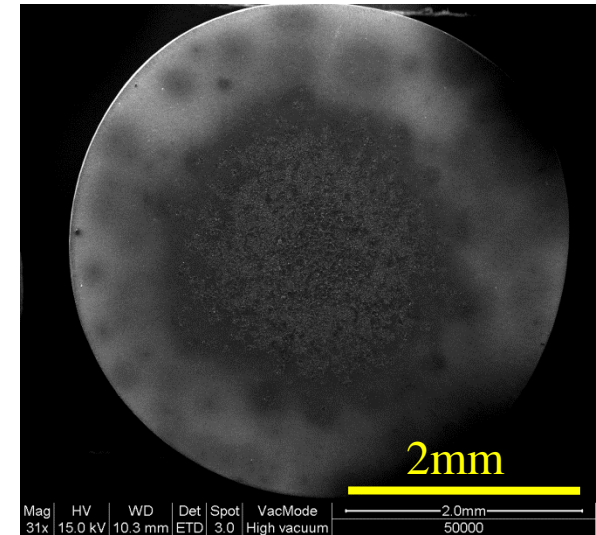
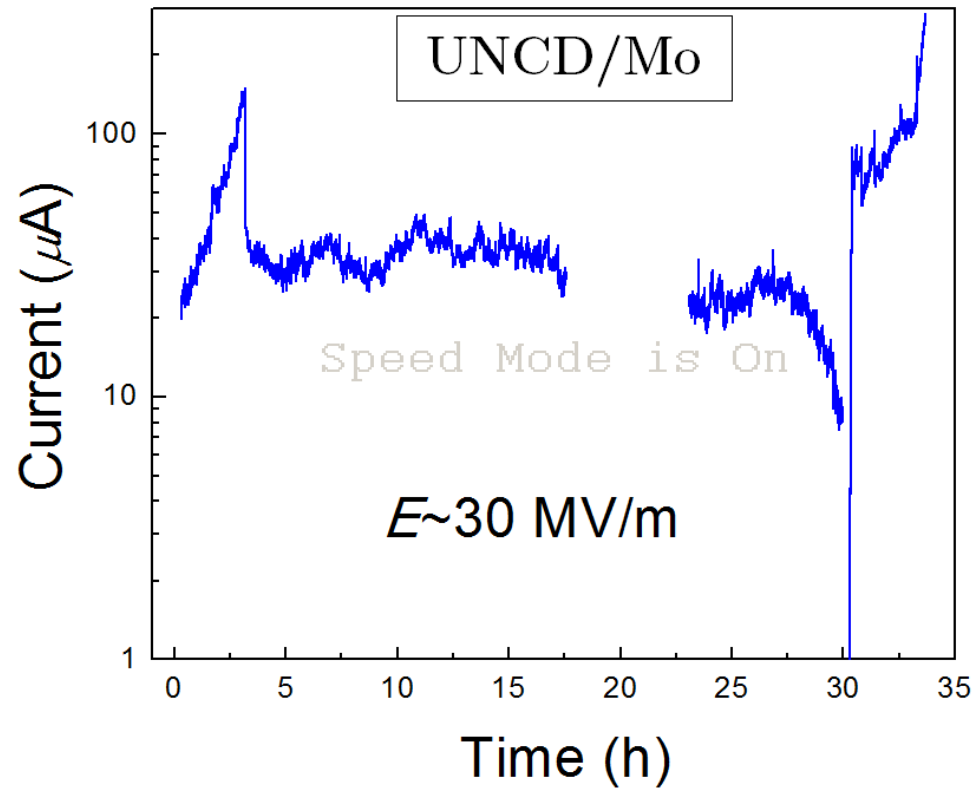
(N)UNCD at DC Test Stand: lifetime test



UNCD/Mo

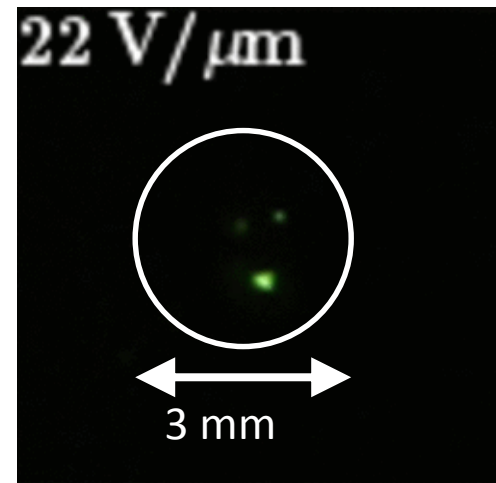
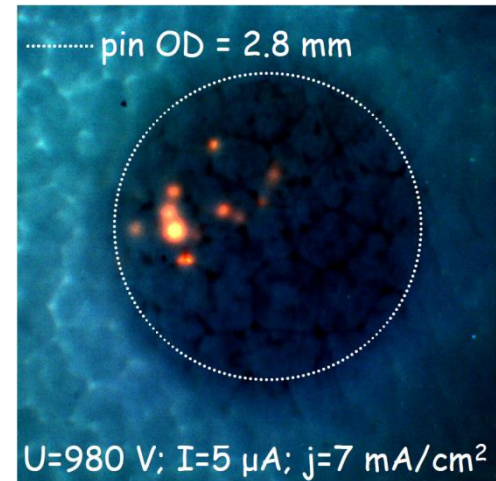
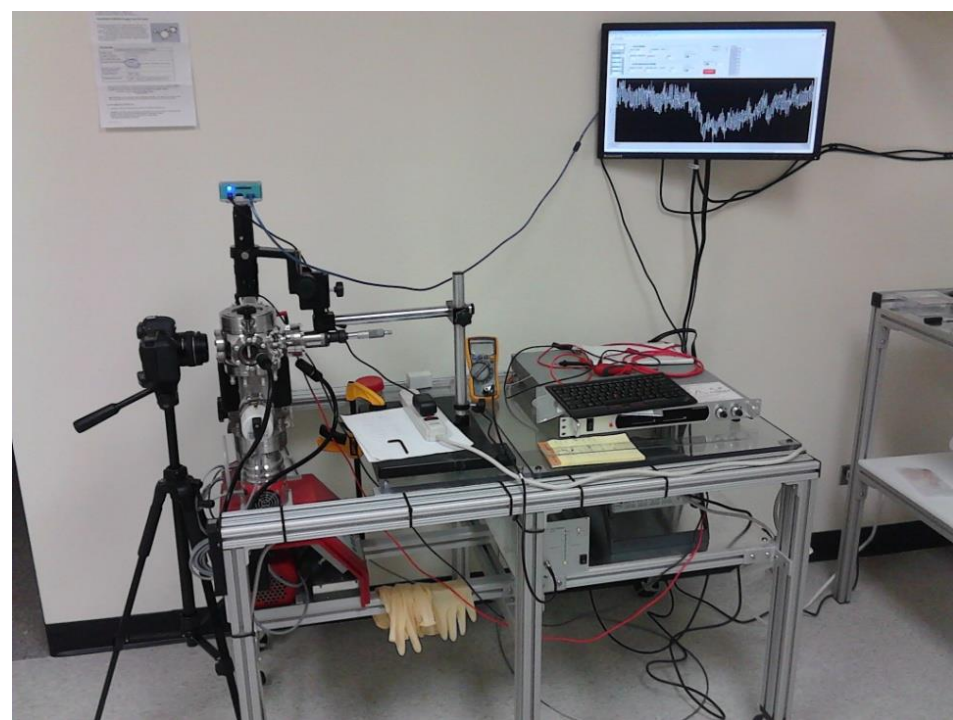


(N)UNCD at DC Test Stand: degradation and breakdown



(N)UNCD at DC Imaging Test Stand

UNCD/Mo/SS: ~5/1000 of total area is emitting



What's going on inside?

Field of view is 4.4 mm

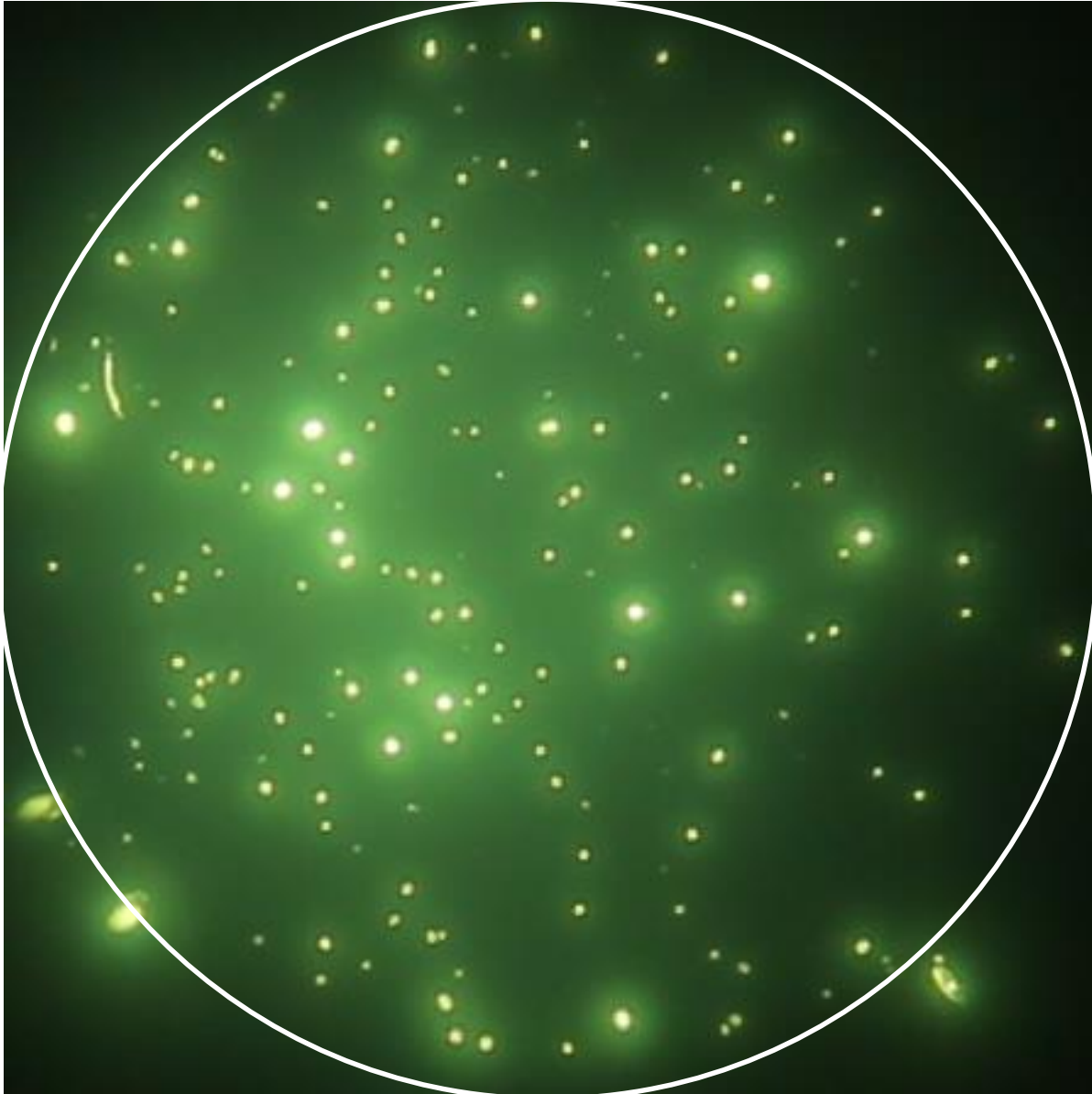
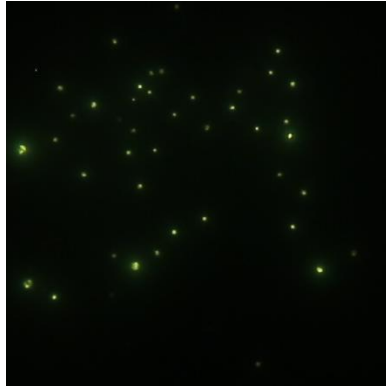
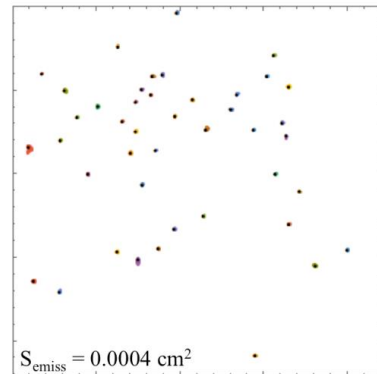
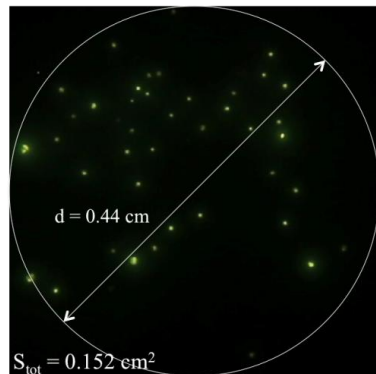
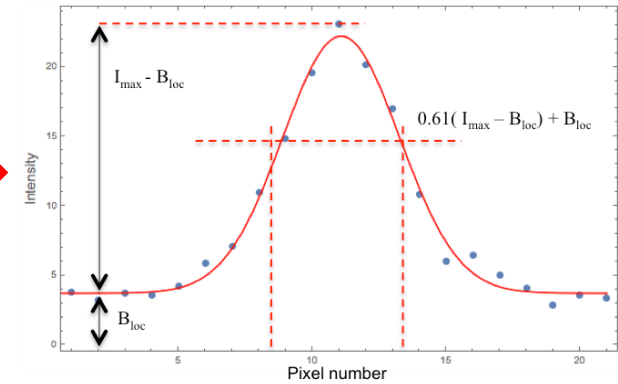
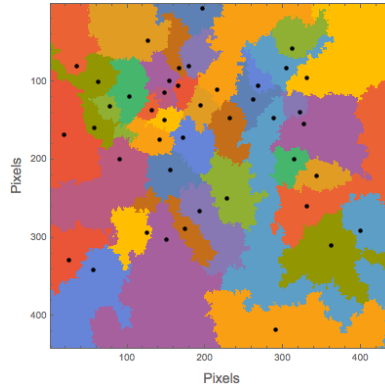
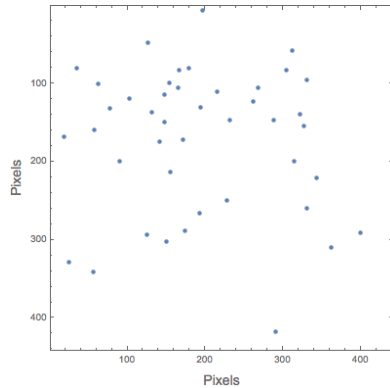
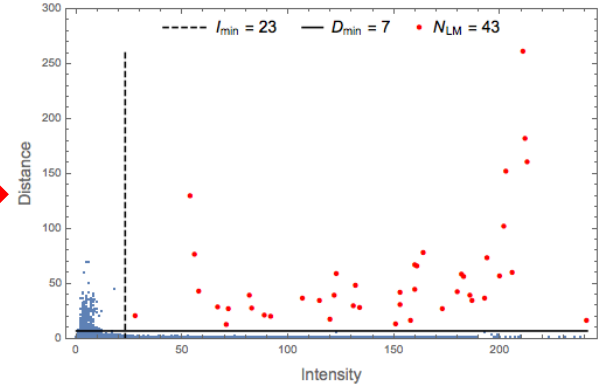


Image processing algorithm



	1	...	j	...	j_{max}
1	$I_{1,1}$...	$I_{1,j}$...	$I_{1,j_{max}}$
...
i	$I_{i,1}$...	$I_{i,j}$...	$I_{i,j_{max}}$
...
i_{max}	$I_{i_{max},1}$...	$I_{i_{max},j}$...	$I_{i_{max},j_{max}}$



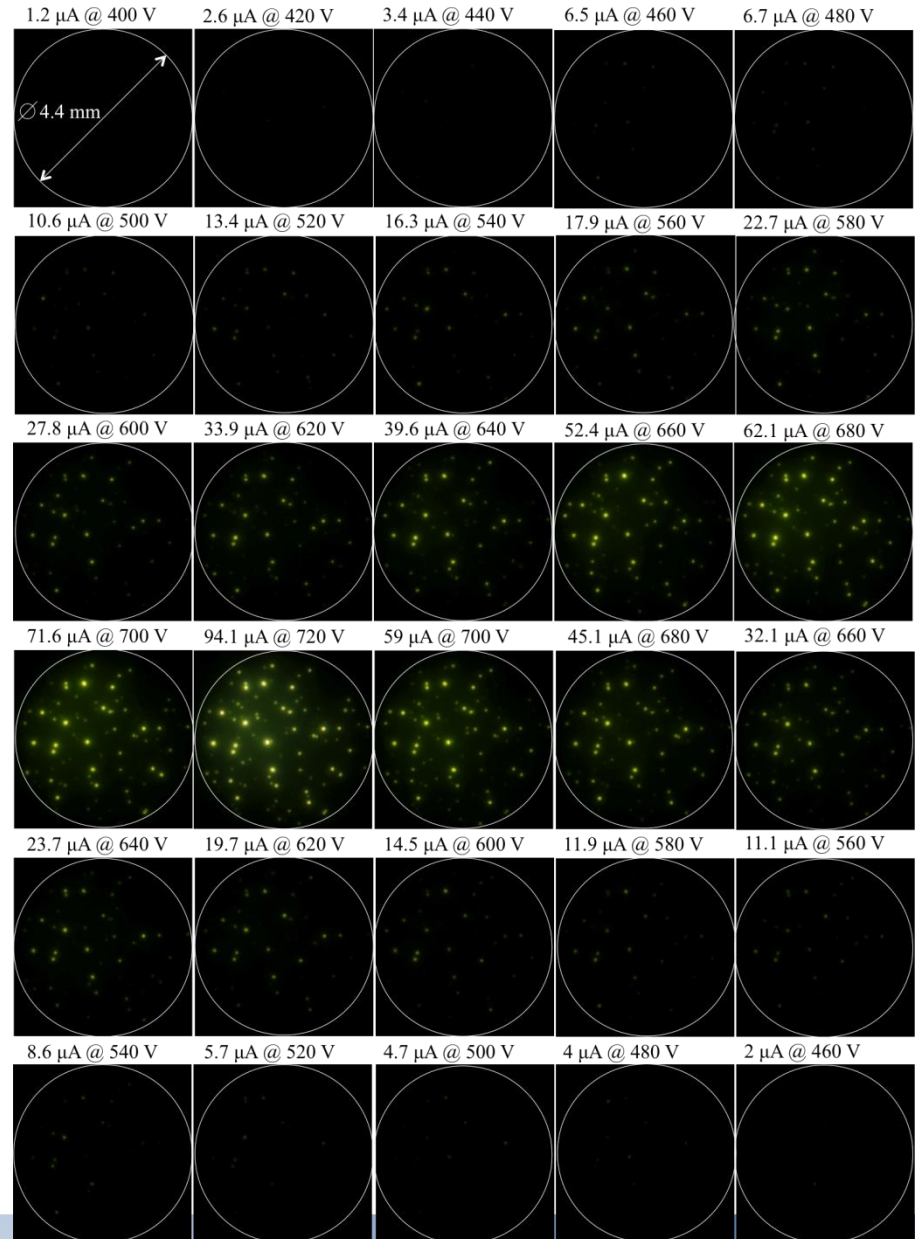
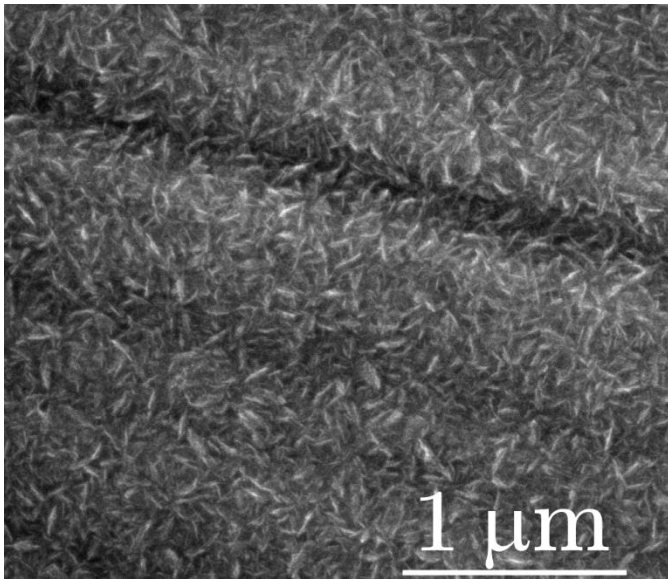
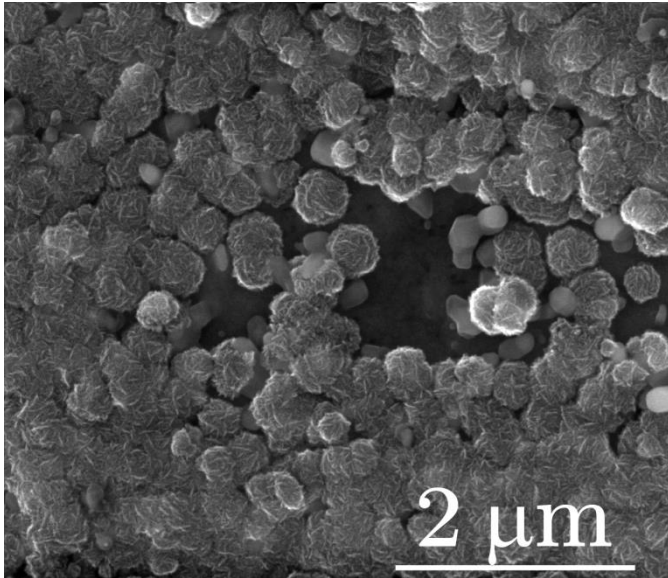
Refs:

Gavriil *et al*, Astrophysical J. **607**, 959 (2004);

Zepka *et al*, Astrophysical J. **427**, 438 (1994);

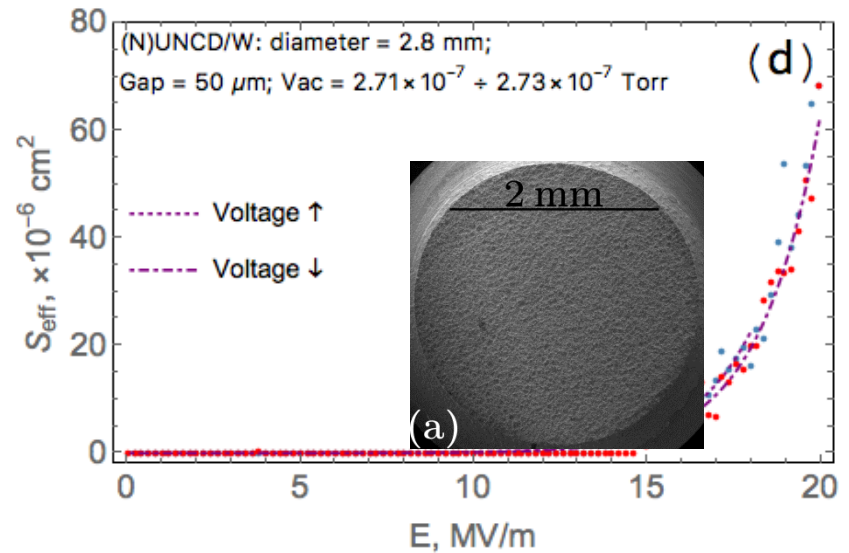
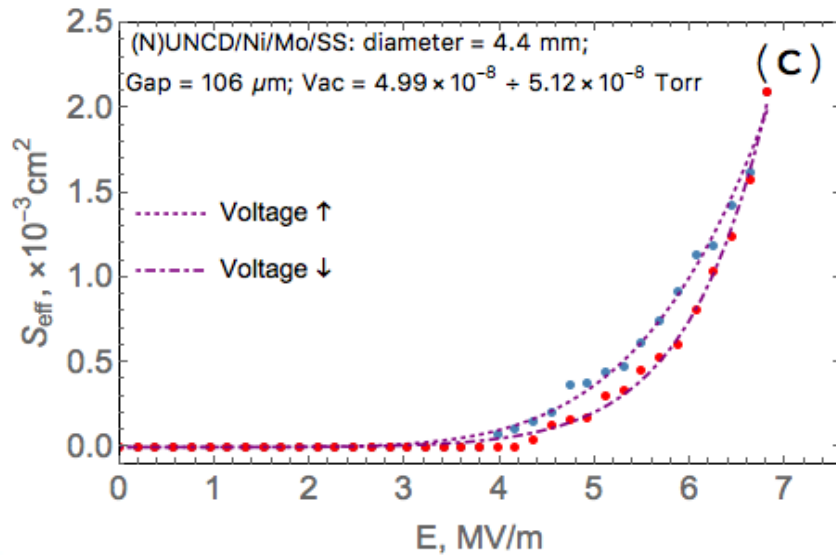
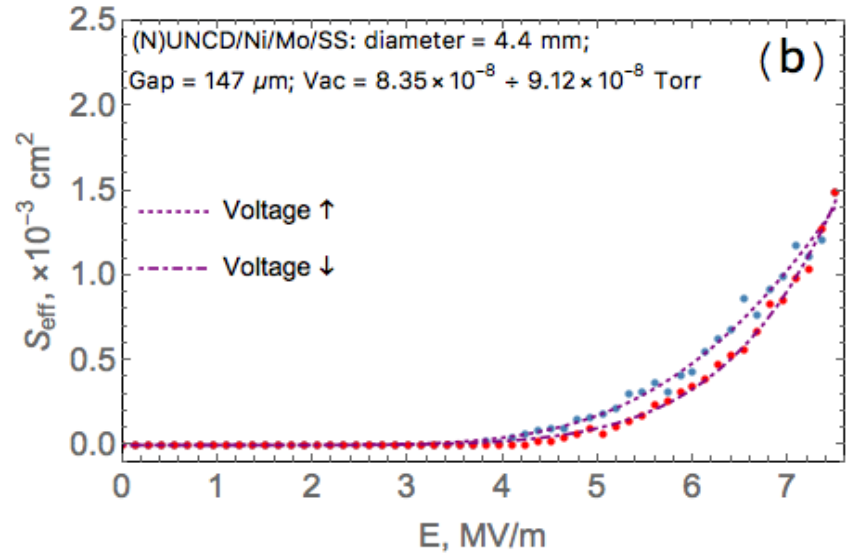
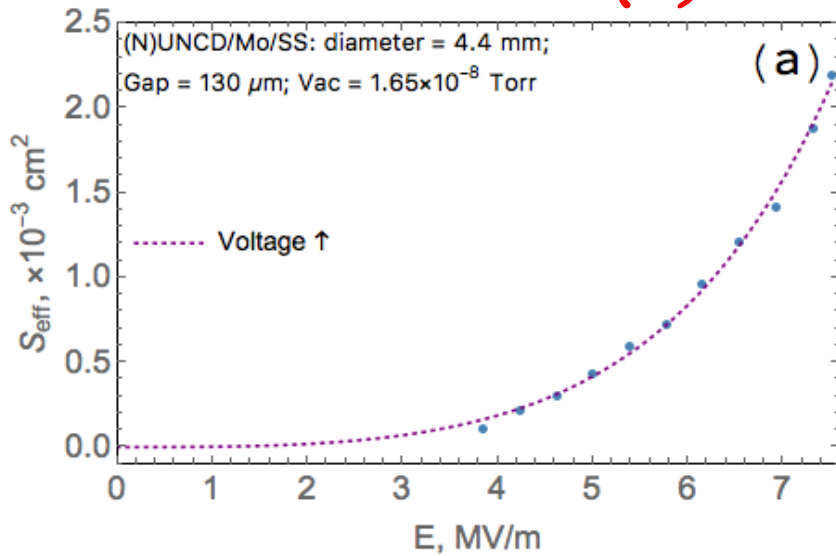
Rodriguez and Laio, Science **344**, 1492 (2014)

Example of a dataset: (N)UNCD/Ni/Mo/SS



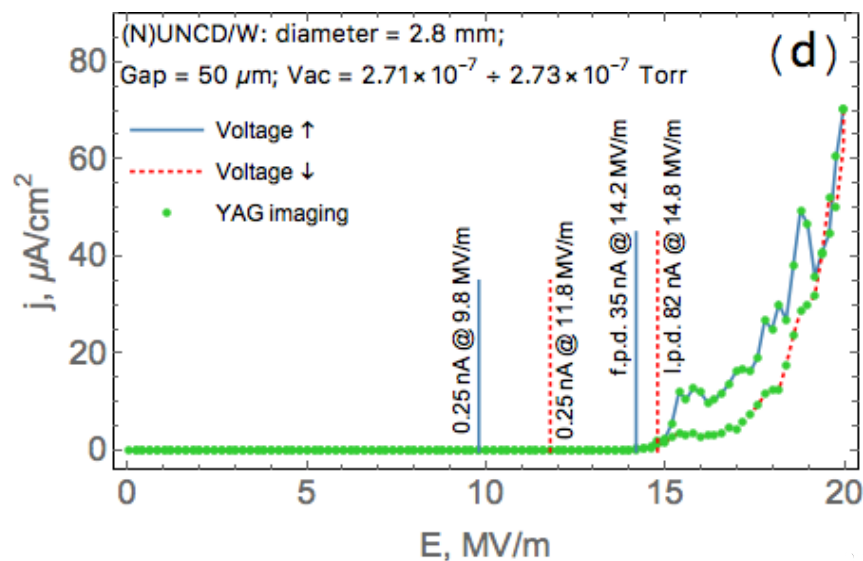
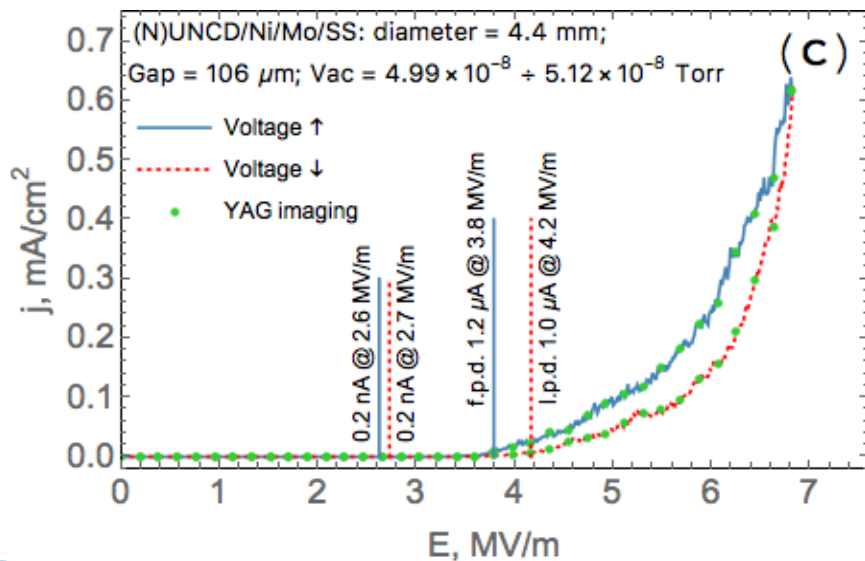
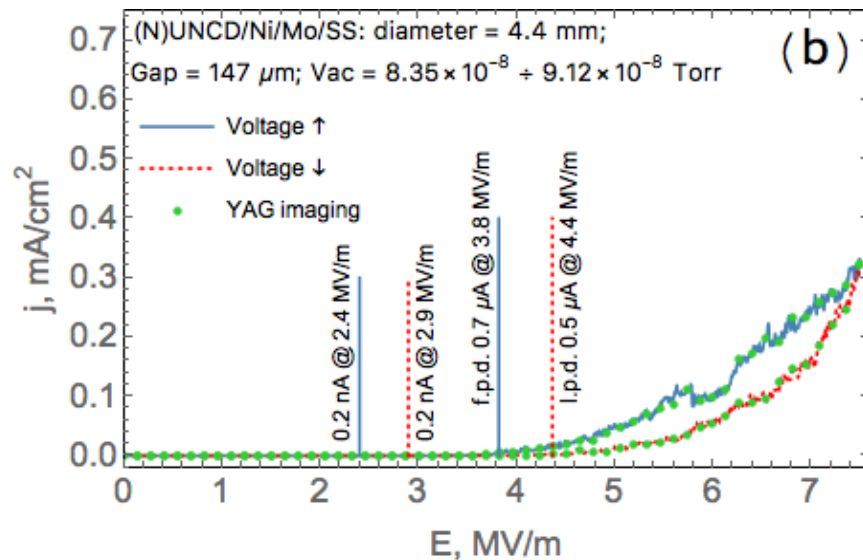
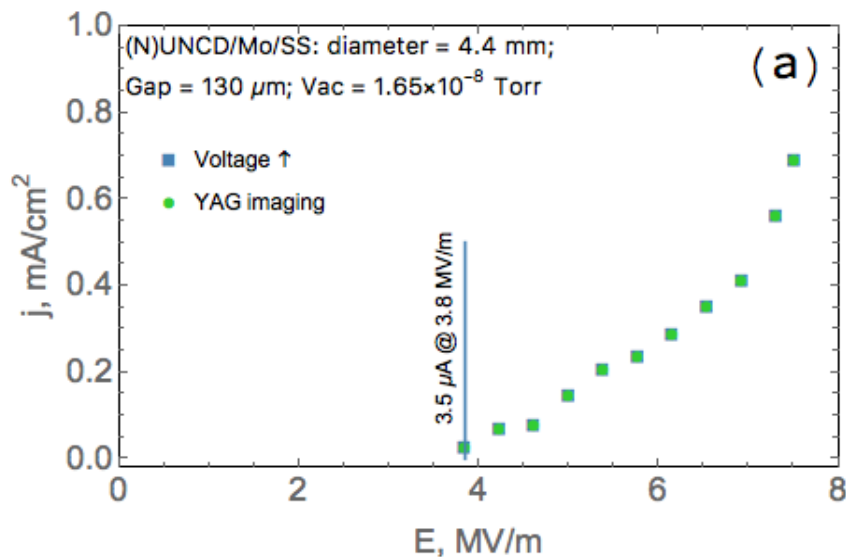
More samples: S depends on E

$S(E)$ is not a const



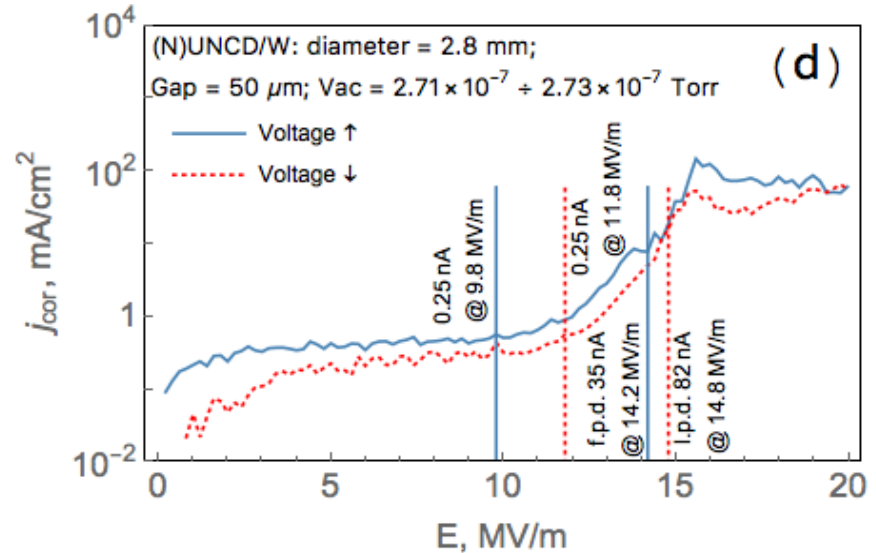
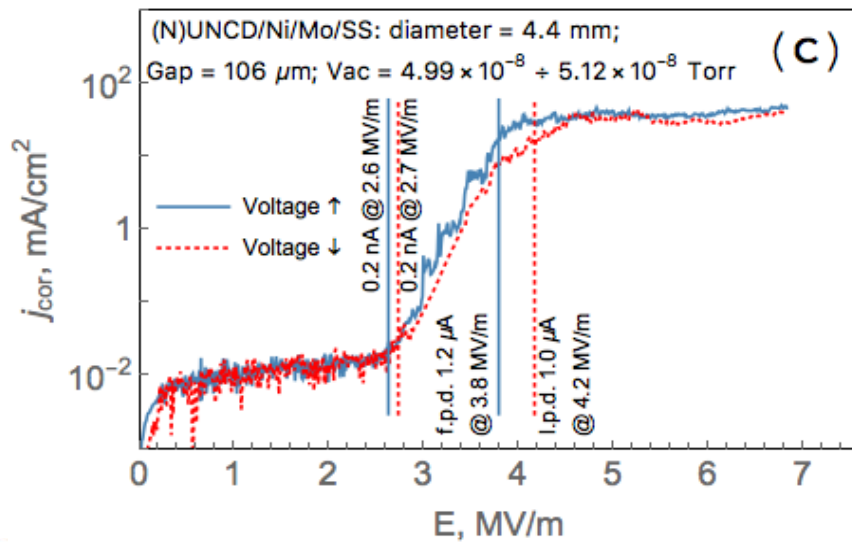
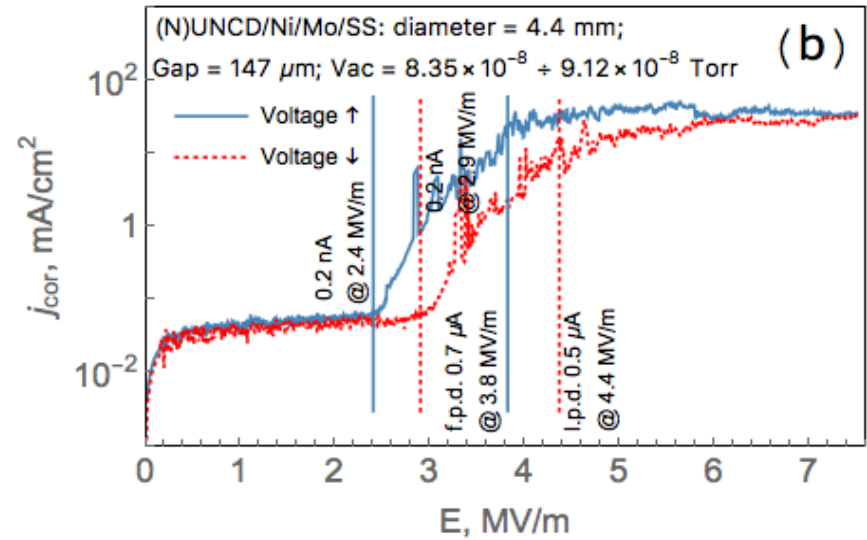
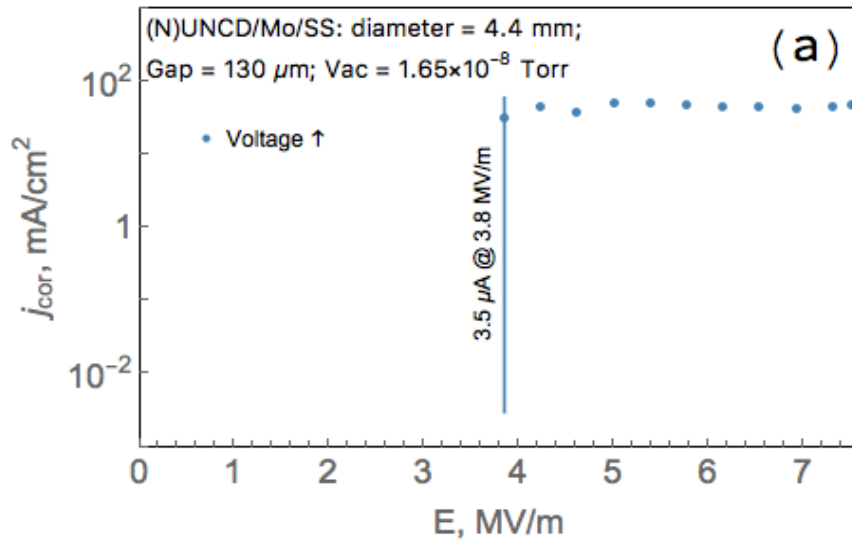
More samples: as measured I - E curves

By convention, $I \rightarrow j$ assuming $S(E) = S_{cathode} = \text{const}$



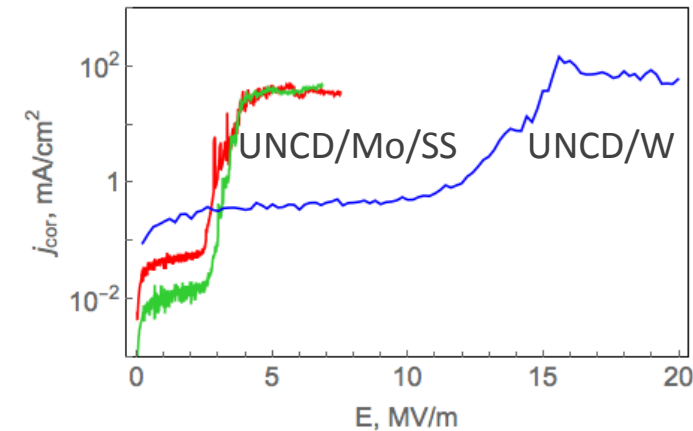
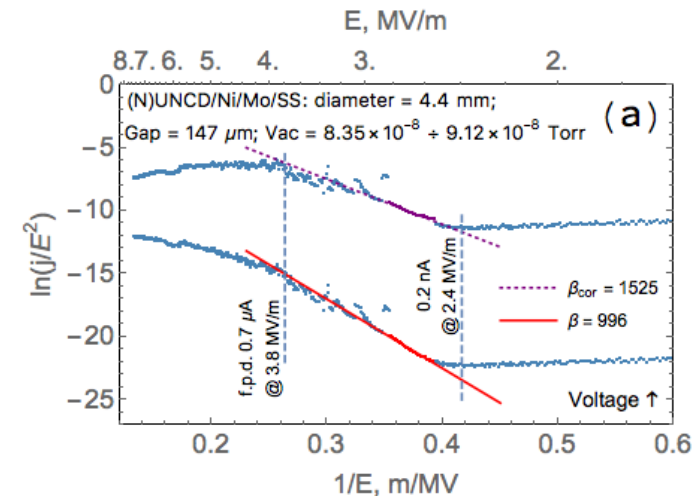
More samples: S-corrected j - E

$$j_{cor} = I/S(E)$$



5 Takeout Notes (Discoveries)

1. Semi-metallic (N)UNCD saturates similarly to semiconductors: **non-FN non-metallic field emitters**
2. In planar uniform (N)UNCD, field emission is not uniform
3. Emission area depends on electric field
4. Saturation is $\sim 100 \text{ mA/cm}^2$ is specific to (N)UNCD, regardless of substrate
5. Roughness and topography are not prerequisites for good FE properties. Chemistry of the substrate is a key



Conclusions

- *n*-type (N)UNCD is a promising field emitter that is already available for RF injectors and other applications (the 1st sale is under contract)
- (N)UNCD is a remarkable platform to keep finding and understanding fundamental processes in field emitters

Next

- More tests are scheduled at ACT (AWA Cathode Teststand) to in-situ image the UNCD emission under high gradient RF.
- Expand DC imaging system capable of measuring MTE of UNCD emitter

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